



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2829
Examiner: J. Hollington

In Re NEW PATENT APPLICATION Of:

Applicant: Mikio OHTAKI

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Appln. No.: 09/904,663

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Filed: July 16, 2001

)

For: METHOD FOR MANUFACTURING
AND BATCH TESTING
SEMICONDUCTOR DEVICES
(As Amended)

**AMENDMENT
AFTER FINAL**

Atty Ref.: KAN 120D1

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April 10, 2003

Commissioner for Patents
Washington, D.C. 20231
BOX - AF

Sir:

Responsive to the Examiner's Action dated December 10, 2002, a Petition
for a One-Month Extension of Time being submitted herewith, please amend the
application as follows:

IN THE SPECIFICATION

Please replace the title on page 1 of the Specification with the following:

--METHOD FOR MANUFACTURING AND BATCH TESTING

SEMICONDUCTOR DEVICES --

FEES RECEIVED: \$ 110
Please charge any further
fee to our Deposit Account
No. 12-3332

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